

Appl. No. 10/800,450  
Amdt. Dated August 5, 2005  
Reply to Office action of February 8, 2005

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/800,450  
Applicant : Emmanuel Hadji, et al.  
Filed : March 15, 2004  
Title : METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A  
SUPPORT AND USE OF SAID METHOD IN THE PRODUCTION  
OF OPTICAL COMPONENTS

Confirm No. : 1230  
TC/A.U. : 2825  
Examiner : Chuong A. Luu

Docket No. : 33019US1

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT A**

Sir:

This amendment is filed in response to the Office action dated February 8, 2005. The three-month period for responding to the Office action expired on May 8, 2005. Accordingly, applicants request and hereby petition for a three-month extension of time up to and including August 8, 2005. The Commissioner is authorized to charge our Deposit Account No. 16-0820, Order No. 33019US1 in the amount of \$1020.00 for the fee associated with the three-month extension of time.

Remarks/Arguments begin on page 2 of this paper.

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date indicated below.

Uma L. Lauricia  
Name of Attorney for Applicant(s)

[Signature]  
Signature of Attorney

8.5.05  
Date

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